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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
09/546,174	04/11/2000	1711	1158	JIA 462C1 <i>bmc-q6-279CON</i>	4	20	3

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CONFIRMATION NO. 4793

CORRECTED FILING RECEIPT



OC000000014256854

Date Mailed: 11/01/2004

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Domestic Priority data as claimed by applicant

This application is a CON of 08/958,460 10/28/1997 PAT 6,117,345
 which claims benefit of 60/041,790 04/02/1997

Foreign Applications

If Required, Foreign Filing License Granted: 06/15/2000

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US09/546,174**

Projected Publication Date: None, application is not eligible for pre-grant publication

Non-Publication Request: No

Early Publication Request: No

Title

HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

Preliminary Class

216



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DATE: 10/1/04

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NUMBER OF PAGES INCLUDING THIS PAGE 2

If you have not received all pages of
this transmission, please contact this
Examining Group as soon as possible at
the above telephone number.

Here is the letter that was received
in parent application 08/958,460 setting
forth the full names of the inventors.

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July 7, 2000

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Acknowledged with thanks,
Rabin & Champagne, P.C.
by Wilson C. Lee date 7/10/00

Re: U.S. Patent Application No. 08/958,460
Your Ref.: JIA 462/SMR
Our Ref.: 1468-US-PA

703/308-6642

Dear Mr. Rabin:

Thank you for your e-mail of July 7, 2000. Please be advised that the full names of the inventors W.B. Shieh and J.Y. Wu are respectively Wen-Bin Shieh and Juan-Yuan Wu. Please provide the PTO with this information as soon as possible.

Thank you very much for your kind assistance with this matter. Again, please fax us the Issue Notification as soon as you have received it.

Yours faithfully,

JIANQ CHYUN
INTELLECTUAL PROPERTY OFFICE


Wilson C. Lee

WILL (s)